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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 15540-011001	Application No 10/660,790	
Inf rmati n Disclosure Statement by Applicant		Applicant Stefan Fliss		OCT 0 8 2003
(Use several sh (37 CFR §1.98(b))	s if necessary)	Filing Date September 12, 2003	Group Art Unit	THE TRADEMENT

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
RAR	AA	4,691,106	Sept. 1, 1987	Hyun et al.			

Other Documents (include Author, Title, Date, and Place of Publication)				
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RAR	AB	Dowden, S. et al., "Reflectometer for fast measurements of mirror reflectivity," Measurement Science and Technology, IOP Publishing, Bristol, GB, Bd. 8, Nr. 11, pp. 1258-1261 (1997).		
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Examiner Signature	Date Considered 04/27/2006			
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